

EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|--|------------------------------|------------------|---------|------------------|
| S1 | 1 | ("6814814").PN. | US-PGPUB; USPAT; USOCR | OR | OFF | 2007/10/10 19:52 |
| S2 | 1 | ("7063094").PN. | US-PGPUB; USPAT; USOCR | OR | OFF | 2007/10/11 09:26 |
| S3 | 2261 | (134/1).CCLS. | US-PGPUB; USPAT; USOCR | OR | OFF | 2007/10/11 09:26 |
| S4 | 2845 | (134/2).CCLS. | US-PGPUB; USPAT; USOCR | OR | OFF | 2007/10/11 09:26 |
| S5 | 2693 | (134/3).CCLS. | US-PGPUB; USPAT; USOCR | OR | OFF | 2007/10/11 09:27 |
| S6 | 1876 | (134/6).CCLS. | US-PGPUB; USPAT; USOCR | OR | OFF | 2007/10/11 09:27 |
| S7 | 2049 | (134/26).CCLS. | US-PGPUB; USPAT; USOCR | OR | OFF | 2007/10/11 09:27 |
| S8 | 506 | (134/27).CCLS. | US-PGPUB; USPAT; USOCR | OR | OFF | 2007/10/11 09:27 |
| S9 | 1255 | (134/28).CCLS. | US-PGPUB; USPAT; USOCR | OR | OFF | 2007/10/11 09:27 |
| S10 | 1036 | (134/29).CCLS. | US-PGPUB; USPAT; USOCR | OR | OFF | 2007/10/11 09:27 |
| S13 | 995 | S3 and ((clean\$4 or etch\$4 or treat\$4 or rins\$4) same (substrate or wafer or semiconductor or electronic)) | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 09:30 |
| S14 | 1392 | S4 and ((clean\$4 or etch\$4 or treat\$4 or rins\$4) same (substrate or wafer or semiconductor or electronic)) | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 09:29 |
| S15 | 913 | S5 and ((clean\$4 or etch\$4 or treat\$4 or rins\$4) same (substrate or wafer or semiconductor or electronic)) | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 09:29 |
| S16 | 543 | S6 and ((clean\$4 or etch\$4 or treat\$4 or rins\$4) same (substrate or wafer or semiconductor or electronic)) | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 09:29 |
| S17 | 89 | S8 and ((clean\$4 or etch\$4 or treat\$4 or rins\$4) same (substrate or wafer or semiconductor or electronic)) | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 09:29 |

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|-----|------|--|------------------------------|----|----|------------------|
| S18 | 408 | S9 and ((clean\$4 or etch\$4 or treat\$4 or rins\$4) same (substrate or wafer or semiconductor or electronic)) | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 09:29 |
| S19 | 1065 | S7 and ((clean\$4 or etch\$4 or treat\$4 or rins\$4) same (substrate or wafer or semiconductor or electronic)) | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 09:29 |
| S20 | 270 | S10 and ((clean\$4 or etch\$4 or treat\$4 or rins\$4) same (substrate or wafer or semiconductor or electronic)) | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 09:29 |
| S21 | 337 | "134"/\$.ccls. and ((rub\$4 or scrub\$4 or wip\$4 or brush\$3) same acid same (substrate or wafer or semiconductor or electronic)) | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 09:54 |
| S22 | 221 | "134"/\$.ccls. and ((rub\$4 or scrub\$4 or wip\$4 or brush\$3) same alcohol same (substrate or wafer or semiconductor or electronic)) | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 09:56 |
| S23 | 55 | "134"/\$.ccls. and ((rub\$4 or scrub\$4 or wip\$4 or brush\$3) same acid same alcohol same (substrate or wafer or semiconductor or electronic)) | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 10:47 |
| S24 | 12 | "134"/\$.ccls. and ((rub\$4 or scrub\$4 or wip\$4 or brush\$3) same ketone same alcohol same (substrate or wafer or semiconductor or electronic)) | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 10:29 |
| S25 | 40 | shih-hong.in. | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 10:31 |
| S27 | 13 | chen-anthony.in. | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 10:35 |
| S28 | 0 | tan-sok.in. | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 10:30 |
| S29 | 5 | hwang-stephen.in. | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 10:35 |
| S30 | 17 | daugherty-john.in. | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 10:35 |
| S31 | 11 | morel-bruno.in. | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 10:35 |
| S32 | 19 | "134"/\$.ccls. and ((clean\$4 or etch\$4 or treat\$4 or rins\$4) same acetone same (hydrogen near2 peroxide) same (substrate or wafer or semiconductor or electronic)) | US-PGPUB; USPAT; USOCR | OR | ON | 2007/10/11 10:49 |